3. (Amended Once) The method of Claim 1 wherein said coating is carried out prior to placing said sorbent structure inside said gas duct.

5. (Amended Once) An apparatus for removing a vapor-phase contaminant from a contaminated gas stream in a duct, said apparatus comprising:

at least one sorbent structure;

a means for coating fresh sorbent onto said sorbent structure;

a means for passing a contaminated gas over said sorbent structure having said fresh sorbent thereon to produce saturated sorbent; and

a means for removing and collecting said saturated sorbent.

Please add the following new Claims 6-17 as follows:

-- 6. (New) Amethod for removing a vapor-phase contaminant from a gas stream, comprising:

coating a non-porous sorbent structure positioned in a gas duct with a sorbent;

passing a gas stream comprising a vapor-phase contaminant through the gas duct;

contacting the vapor-phase contaminant with the sorbent, thereby adsorbing the vaporphase contaminant onto the sorbent;

removing the sorbent having the adsorbed vapor-phase contaminant from the gas duct;

recoating the non-porous sorbent structure with fresh sorbent.

- 7. (New) The method of Claim 6, wherein the coating comprises attracting the sorbent to the non-porous sorbent structure using an attractive force.
- 8. (New) The method of Claim 7, wherein the attracting comprises attracting the sorbent to the non-porous sorbent structure using an attractive force selected from the group consisting of electrostatic attraction, magnetic attraction, gravitational attraction, van der Waals attraction, and combinations thereof.

- 9. (New) The method of Claim 6, wherein the coating comprises magnetically attracting the sorbent to the non-porous sorbent structure.
- 10. (New) The method of Claim 9, wherein the removing comprises demagnetizing the sorbent and the sorbent structure.
- 11. (New) The method of Claim 6, wherein the non-porous sorbent structure is selected from the group consisting of tubes, plates, monoliths, walls, vanes and combinations thereof.
- 12. (New) The method of Claim 6, wherein the vapor-phase contaminant comprises mercury.
- 13. (New) The method of Claim 6, wherein the recoating comprises attracting the fresh sorbent to the non-porous sorbent structure using an attractive force selected from the group consisting of electrostatic attraction, magnetic attraction, gravitational attraction, van der Waals attraction, and combinations thereof.
 - 14. (New) The method of Claim 6, wherein the recoating comprises: removing the non-porous sorbent structure from the gas duct; applying the fresh sorbent to the non-porous sorbent structure; and repositioning the non-porous sorbent structure in the gas duct.
- 15. (New) The method of Claim 6, wherein the recoating comprises recoating the non-porous sorbent structure with the fresh sorbent while the non-porous sorbent structure remains in the gas duct.
- 16. (New) A method for removing a vapor-phase contaminant from a gas stream, comprising:

coating a sorbent structure positioned in a gas duct with a sorbent, wherein the coating comprises magnetically attracting the sorbent to the sorbent structure;

passing a gas stream comprising a vapor-phase contaminant through the gas duct;

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and

contacting the vapor-phase contaminant with the sorbent, thereby adsorbing the vapor-phase contaminant onto the sorbent;

removing the sorbent having the adsorbed vapor-phase contaminant from the gas duct;

repeating the coating with fresh sorbent.

cont.

17. (New) An apparatus for removing a vapor-phase contaminant from a gas stream, comprising:

a gas duct;

a magnetized sorbent structure positioned in said gas duct; and

a sorbent attached to said magnetized sorbent structure,

wherein said magnetized sorbent structure is configured to be periodically demagnitized, thereby allowing said sorbent to become detached from said magnetized sorbent structure. –